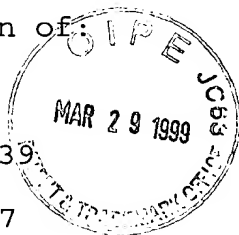


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:)
NISHIMOTO et al)
Serial No.: 08/897,839)
Filed: July 21, 1997)
For: STRESS-ADJUSTED INSULATING)
FILM FORMING METHOD,)
SEMICONDUCTOR DEVICE AND)
METHOD OF MANUFACTURING THE)
SAME)



Group Art Unit: 2814

Examiner: K. Eaton

5/10/99
G. Stanley
4-8-99

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

It is respectfully requested that the time period for filing a response to the office action of October 29, 1998, initially set to expire January 29, 1999, be extended two months up to and including March 29, 1999. The requisite \$380.00 fee for the requested extension is herewith attached.

Any additional fees may be charged to our Deposit Account No. 12-2174. A duplicate copy of this sheet is attached.

Respectfully submitted,

George A. Loud
Reg. No. 25,814

Dated: March 29, 1999

LORUSSO & LOUD
3137 Mt. Vernon Avenue
Alexandria, VA 22305

(703) 739-9393

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